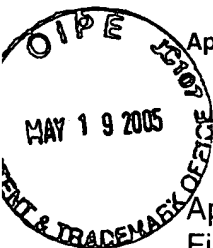


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Appl. No. 10/734,419

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.10/734,419
Filing Date December 11, 2003
Inventor John T. Moore et al.
Assignee Micron Technology, Inc.
Examiner Warren, Matthew E.
Group Art Unit 2815
Customer No.021567
Attorney Docket No.MI22-2463
Title: Semiconductor Wafer Assemblies Comprising Photoresist Over Silicon Nitride
Materials

RESPONSE TO MAY 9, 2005 OFFICE ACTION

To: Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

AMENDMENTS

Introductory Comments

In reply to the office action dated May 9, 2005, applicant amends and remarks as follows.